

Initial Information Data Sheet

Inventor Information

Inventor One Given Name: Hiroshi
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Inventor Two Given Name: Shinichi
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Inventor Three Given Name: Takeshi
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Correspondence Information

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Application Information

Title Line One: SEMICONDUCTOR DEVICE
Title Line Two: MANUFACTURING SYSTEM
Title Line Three: AND ELECTRON BEAM
Title Line Four: EXPOSURE APPARATUS
Total Drawing Sheets: 8
Formal Drawings?: Yes
Application Type: Non-provisional
Docket Number: 514802001100

Representative Information

Representative Customer Number:



25224

PATENT TRADEMARK OFFICE

Continuity Information

This application is a:
> Application One:
Filing Date:

which is a:
>>Application Two:
Filing Date:

which is a:
>>>Application Three:
Filing Date:

Prior Foreign Applications

Foreign Application One: 2000-304245
Filing Date: October 3, 2000
Country: Japan
Priority Claimed: Yes

Assignee Information

Assignee: ADVANTEST CORPORATION

2000-304245